

Notice of References Cited	Application/Control No. 10/531,172	Applicant(s)/Patent Under Reexamination TETSUJI ET AL.	
	Examiner Mark Kopec	Art Unit 1751	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,918,051	04-1990	Mantese et al.	505/446
*	B	US-5,122,510	06-1992	Chen et al.	505/430
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 01-111713	04-1989	JP		
	O	JP 2002-075079	03-2002	JP		
	P					
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	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"Solution Processing of YBa ₂ Cu ₃ O _{7-x} thin films...", Mater. Res. Soc. Symp. Proc. 1998(495), 203-208.
	V	
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.